Search Notes



| Application/Control No. | Applicant(s)/Patent Under Reexamination |
|-------------------------|---|
| 10550450 | ICHIMURA ET AL. |
| Examiner | Art Unit |
| Zhu, John | 2858 |

| SEARCHED | |
|----------|----------|
| class | Date |
| | 7/9/2006 |

| Class | Subclass | Date | Examiner |
|-------|----------|----------|----------|
| 324 | 663 | 7/9/2006 | MK |
| 324 | 522 | 7/9/2006 | MK |
| 324 | 713 | 7/9/2006 | MK |
| 324 | 458 | 6/2/07 | JZ |
| 324 | 660 | 6/2/07 | JZ |

| SEARCH NOTES | | |
|--|-----------|----------|
| Search Notes | Date | Examiner |
| search 73/514.01-520.01 wiht keyword for MEMS type sensors | 7/9/2006 | MK |
| Review International search report | 7/9/2006 | MK |
| Update EAST keyword search, see notes | 1/10/2007 | JZ |
| Updated EAST keyword search, see notes for strategy | 6/2/2007 | JZ |

| 01 | Subclass | Date | Examine |
|-------|----------|------|---------|
| Class | Subclass | | |

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